

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Shinji MAEKAWA et al.	
Serial No.:	10/827,457
Filed:	April 19, 2004
For:	Method For Forming Pattern And Drop Discharge Apparatus
Examiner:	Marianne L. Padgett
Art Unit:	1792
Confirm No.:	2984

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT E

Applicants have the following response to the Office Action of January 25, 2008.

Please amend the above-identified application as follows: